

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Yasunori Ito, et al.
Serial No.: 10/640,850
Filed: August 13, 2003
For: METHOD OF PRODUCING
CERAMIC THERMISTOR
CHIPS
Group Art Unit: 1795
Confirmation No.: 9131
Examiner: H. D. Wilkins III
Attorney Docket: MURTP083D1

**CERTIFICATE OF EFS-WEB
TRANSMISSION**

I hereby certify that this correspondence is being transmitted electronically through EFS-WEB to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on November 21, 2008.

Signed: /dn/
Deborah Neill

EXPRESS ABANDONMENT OF APPLICATION (37 CFR 1.138)

Mail Stop Express Abandonment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The applicant hereby expressly abandons this case

Respectfully submitted,

/kn/

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November 21, 2008
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